



GP1763

## PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE  
(Case No. 98,162)

In re Application of: )  
DeGendt, et al. ) Group Art Unit: 1763  
Serial No.: 09/022,834 ) Examiner: Not Yet Assigned  
Filed: February 13, 1998 )  
For: METHOD FOR REMOVING ORGANIC )  
CONTAMINANTS FROM A )  
A SEMICONDUCTOR SURFACE )

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Assistant Commissioner for Patents  
Washington, D.C. 20231

## TRANSMITTAL LETTER

In regard to the above identified application:

1. We are transmitting herewith the attached Preliminary Amendment and return postcard.

2. With respect to additional fees:

A.  An additional fee of \$22.00 is required and has been calculated as shown below:

CLAIM AS AMENDED						
(1)	(2) Claims Remaining After Amendment	(3)	(4) Highest No. Previously Paid For	(5) Present Extra	(6) Rate	(7) Additional Fee
Total Claims	50	Minus	49	1	22.00	\$22.00
Indep. Claims	3	Minus	3	0	82.00	\$ -0-
Total Additional Fee For this Amendment 6					\$22.00	

\* If the entry in Column 2 is less than the entry in Column 4, write "0" in Column 5.

\*\* If the "Highest Number Previously Paid For" IN THIS SPACE is less than 20, write "20" in this space.

\*\*\* Each multiple dependent claim should be counted as the number of claims from which it depends.

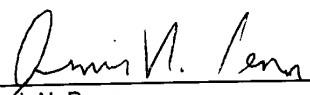
C.  Attached is a check totaling \$22.00

D.  Charge the total additional fee to our Deposit Account No. 13-2490.

A duplicate copy of this sheet is enclosed.

3. Please charge any additional fees or credit overpayment to Deposit Account No. **13-2490**.  
A duplicate copy of this sheet is enclosed.
4. CERTIFICATE OF MAILING UNDER 37 CFR § 1.8: The undersigned hereby certifies that Transmittal Letter and the paper, as described in paragraph 1 hereinabove, are being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Asst. Commissioner for Patents, Washington, D.C. 20231 on this 5th day of November, 1998.

BY:

  
\_\_\_\_\_  
Amir N. Penn  
Reg. No. 40,767

DATED: November 5, 1998



#5 Pre-Amend  
A  
Agreed  
11/23/98

**PATENT**  
**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**  
(Case No. 98,162)

In the Application of:

DeGendt et al.

Serial No.: 09/022,834

Filed: February 13, 1998

Title: Method for Removing Organic  
Contaminants from a Semiconductor  
Surface

Examiner: Not yet assigned

Art Unit: 1763

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**PRELIMINARY AMENDMENT**

Assistant Commissioner for Patents  
Washington, D.C. 20231

Dear Sir:

Please amend the specification in the above-captioned application:

At page 16, lines 4-7, delete [Quarter wafers are used, as such, the exact same wafer is used for all treatments; facilitating relative comparison of the cleaning efficiencies of either process.]

At page 16, lines 23-25, delete [Note that identical wafers and process times were used for all ozone experiments, making the effect even more significant.]

Please amend the following claims in the above-captioned application:

2. A method as recited in claim 1, further comprising the step of adding a gas selected from the group consisting of oxygen, [or] nitrogen [or] and argon to said mixture.

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